

Docket No.: YOR920030367US1

(20140-00310-US1)

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Stefanie R. Chiras et al.

Application No.: 10/722,558

Confirmation No.: 4980

Filed: November 28, 2003

Art Unit: 2812

For:

PROCESS FOR FORMING AN

**ELECTRICALLY CONDUCTIVE** 

INTERCONNECT

Examiner: Not Yet Assigned

## **INFORMATION DISCLOSURE STATEMENT (IDS)**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

The relevance of Cite No. BC can be found on the attached English-language abstract.

A copy of only those references listed below is attached:

For. Doc No.	Ctry	Patentee/Applicant	Publication Date
03/056603	IB	Applied Materials, Inc.	July 10, 2003
1 233 448	EP	Texas Instruments, Inc.	August 21, 2002
2000-323571	JР	Sony Corp.	November 24, 2000

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0510, under Order No. 20140-00310-US1. A duplicate copy of this paper is enclosed.

Dated: February 2, 2005

Respectfully submitted,

Burton A. Amernick

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PTO/SB/08a/b (08-03)

Approved for use through 07/31/2006. OMB 0551-0031

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Substitute for form 1449A/B/PTO				Complete if Known		
INFORMATION DISCLOSURE				Application Number	10/722,558-Conf. #4980	
				Filing Date	November 28, 2003	
STATEMENT BY APPLICANT			PLICANT	First Named Inventor	Stefanie R. Chiras	
	(Use as many she ets as necess ary)			Art Unit	2812	
				Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attomey Docket Number	20140-00310-US1	

U.S. PATENT DOCUMENTS					
Examiner	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where
Initials*	No.1	Number-Kind Code <sup>2</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear
	AA	US-6,498,091-B1	12-24-2002	Chen et al	
	AB	US-6,509,267-B1	01-21-2003	Woo et al	
	AC	US-2002/0060363-A1	05-23-2002	Xi et al	

FOREIGN PATENT DOCUMENTS							
Examiner	Cite	Foreign Patent Document	Publication	Name of Patentee or	Pages, Columns, Lines,	П	
	No.1	Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Date MM-DD-YYYY	Villete Rei	Where Relevant Passages or Relevant Figures Appear		
	ВА	WO-03/056603-A2, A3	07-10-2003	Applied Materials, Inc.		T	
	BB	EP-1 233 448-A2, A3	08-21-2002	Texas Instruments, Inc.		Г	
	BC	JP-2000-323571-A	11-24-2000	Sony Corp.			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at <a href="www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author ( in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner	Date	
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